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(54) **LARGE AREA ORGANIC
ELECTROLUMINESCENT DISPLAY USING
BIMORPH MEMS DEVICES**

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U.S.C. 154(b) by 83 days.

This patent is subject to a terminal dis-
claimer.

(21) Appl. No.: **11/744,246**

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(63) Continuation-in-part of application No. 11/065,157,
filed on Feb. 25, 2005, which is a continuation-in-part
of application No. 10/277,500, filed on Oct. 22, 2002,
now Pat. No. 6,861,810.

(60) Provisional application No. 60/335,216, filed on Oct.
23, 2001, provisional application No. 60/797,692,
filed on May 5, 2006.

(51) **Int. Cl.**
G09G 3/10 (2006.01)

(52) **U.S. Cl.** **315/169.3; 345/45; 345/46;
345/55**

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345/60, 76, 77, 78, 82, 83, 84, 87, 91, 92,
345/102, 204, 207, 211, 212, 213, 214; 257/40,
257/59, 72, 79, 88, 89, 90, 94, 96, 98, 99,
257/100, 103, 296, 344, 350, 351, 408, 435,
257/443, E33.056, E31.052, E51.044, E51.047,
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257/E51.022, E33.064

See application file for complete search history.

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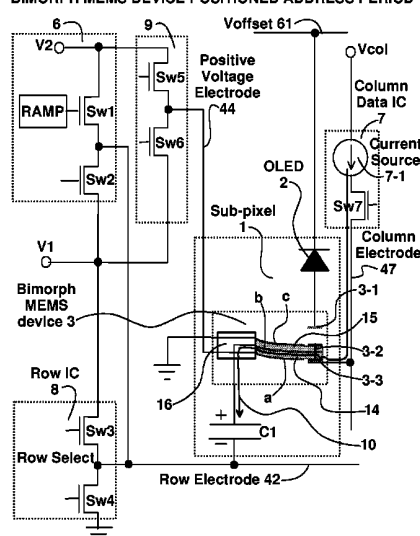
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(57) **ABSTRACT**

An active matrix organic LED display having a matrix of
multiple light emitting pixels and electronic drive circuitry
for selectively addressing the pixels, each pixel containing an
organic LED. The electronic drive circuitry includes row scan
electrodes and column data electrodes that interconnect the
matrix of pixels. The circuitry also includes a MEMS switch-
ing device and a memory capacitor for each pixel, the MEMS
switching device connecting the memory capacitor to a col-
umn data electrode during addressing of a pixel and connect-
ing the memory capacitor to the organic LED of each pixel
during light emission.

14 Claims, 6 Drawing Sheets

BIMORPH MEMS DEVICE POSITIONED ADDRESS PERIOD



BIMORPH MEMS DEVICE POSITIONED ADDRESS PERIOD

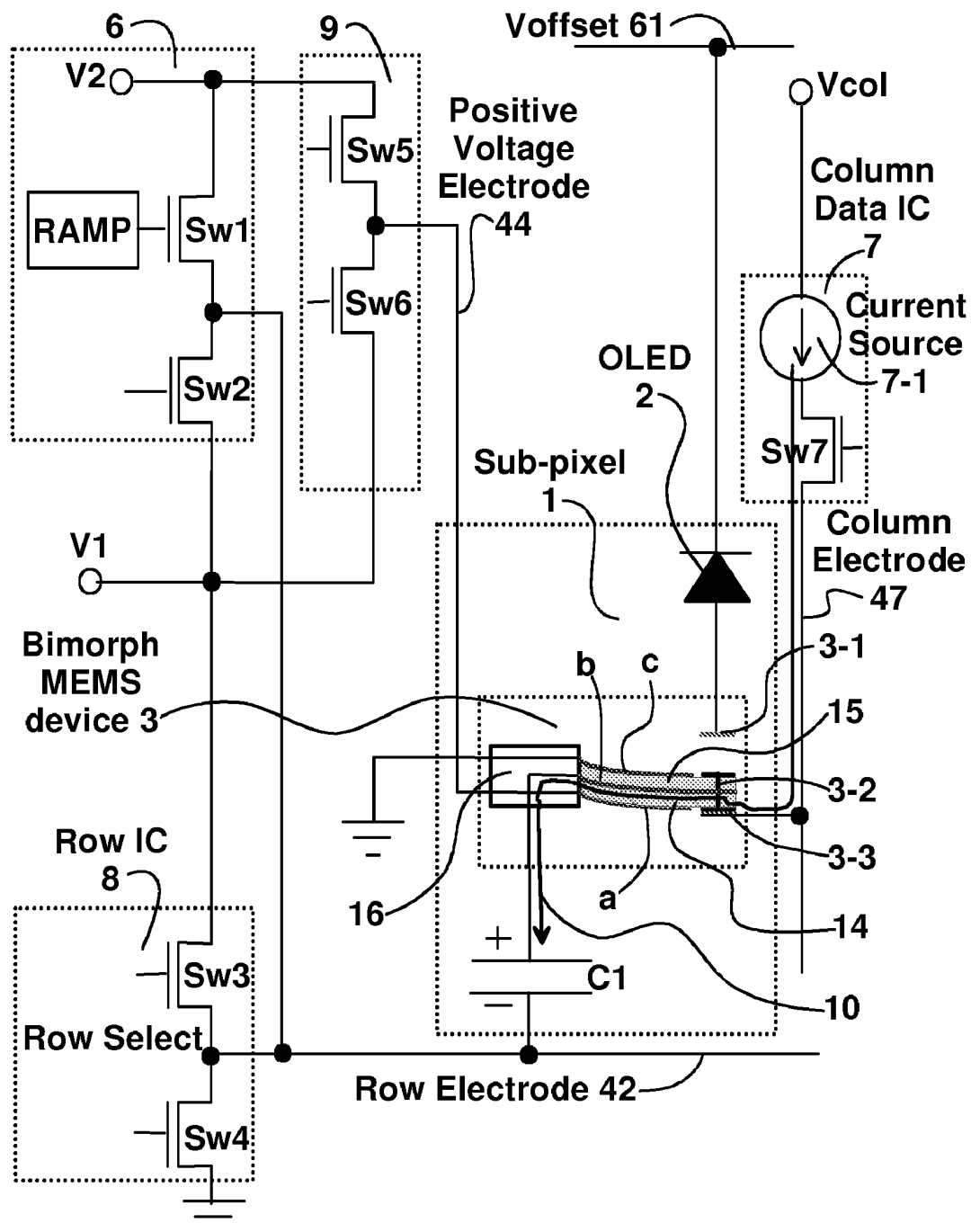


Figure 1

[illegible]

Figure 2

BIMORPH MEMS DEVICE CENTER OFF POSITION

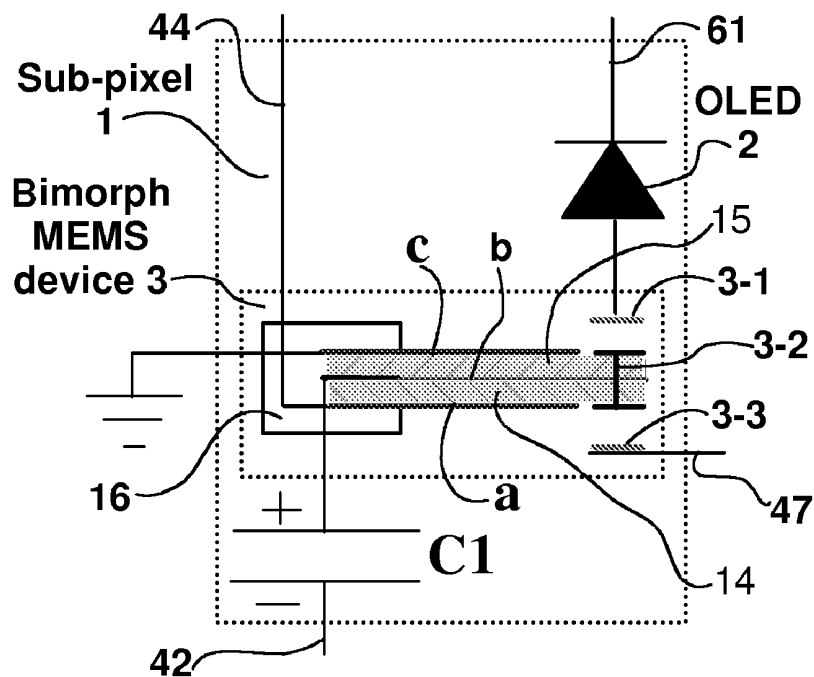


Figure 3

ELECTRODE WAVEFORMS

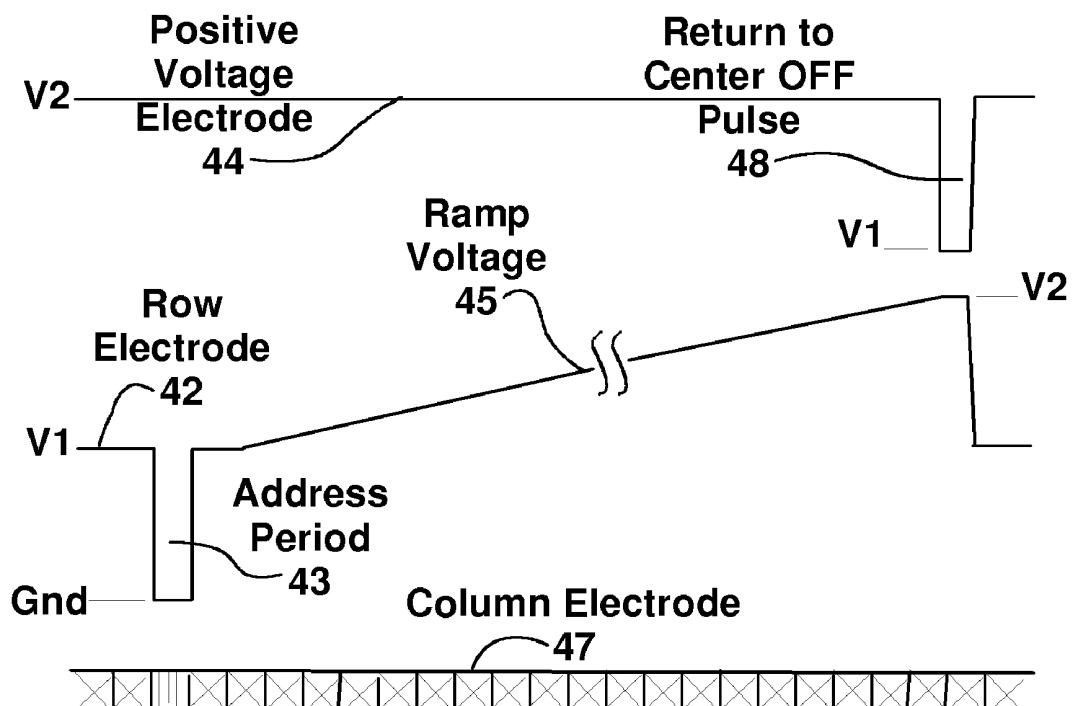
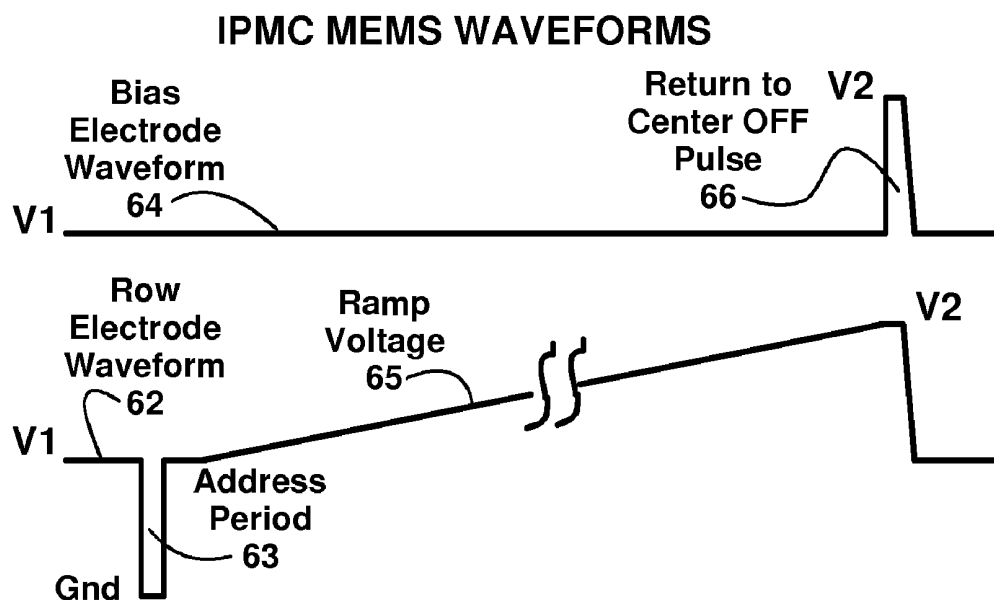
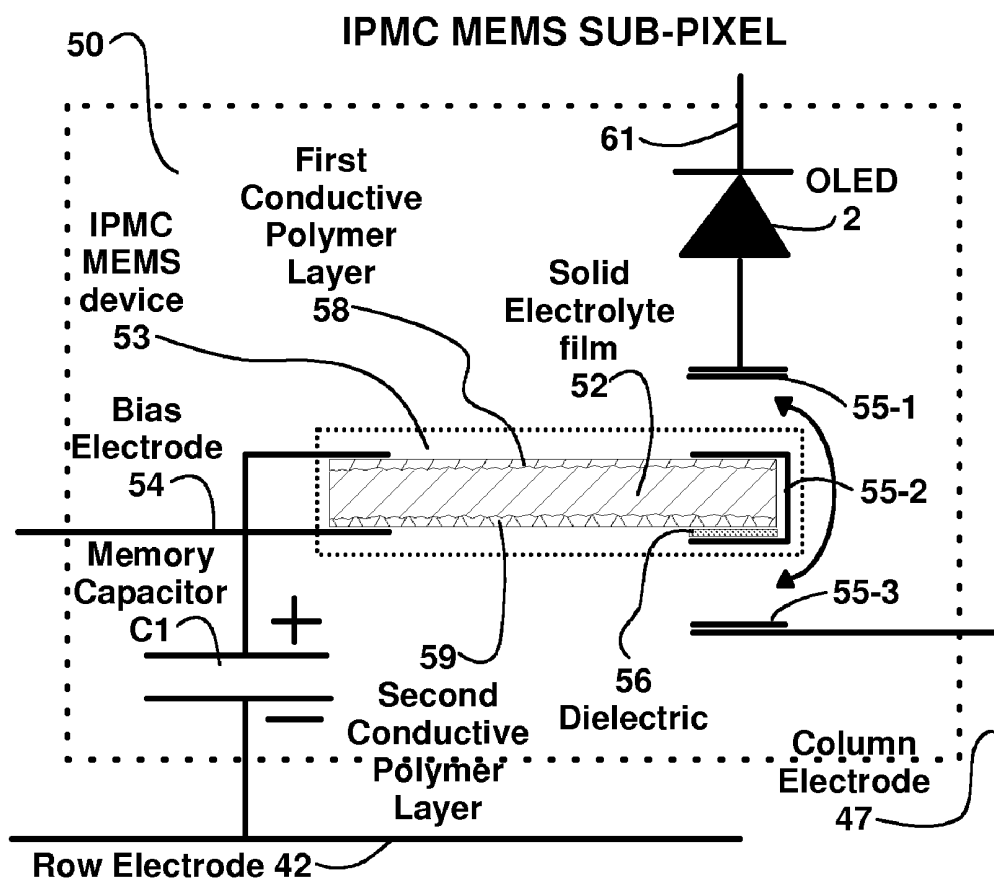


Figure 4

**Figure 6**

SINGLE SUBSTRATE STRUCTURE

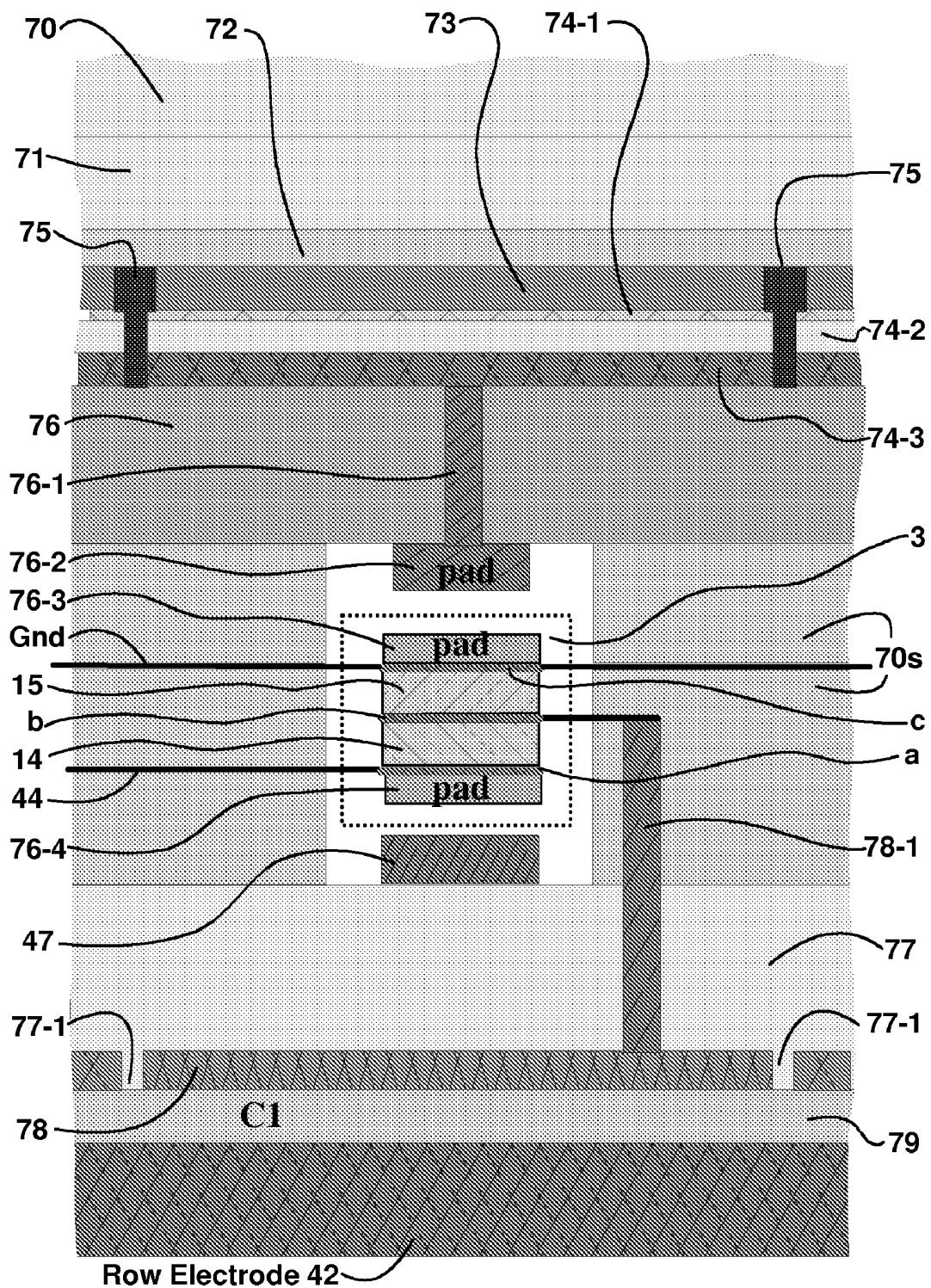


Figure 7

DUAL SUBSTRATE STRUCTURE

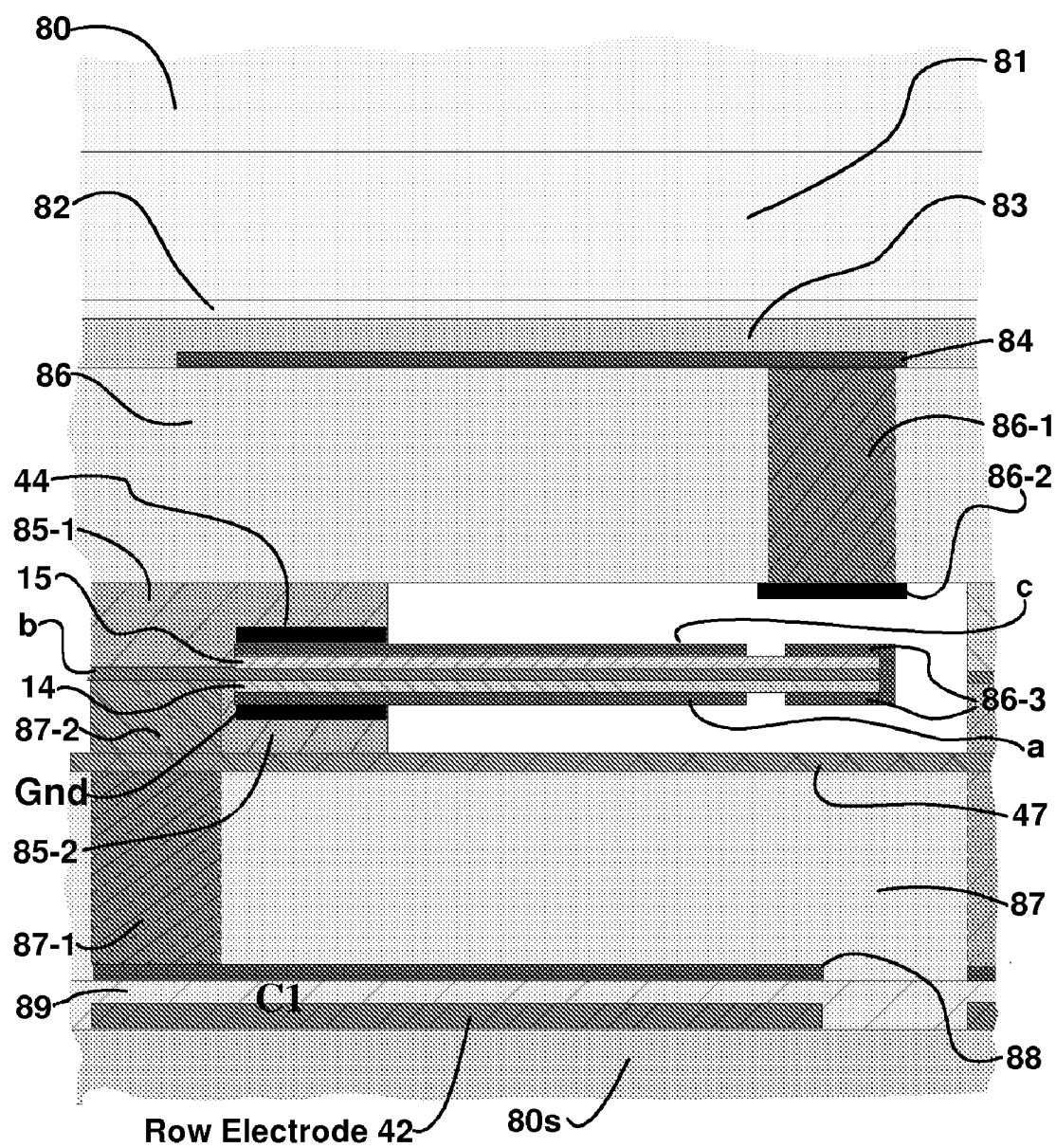


Figure 8

LARGE AREA ORGANIC ELECTROLUMINESCENT DISPLAY USING BIMORPH MEMS DEVICES

RELATED APPLICATIONS

This is a continuation in part under 35 U.S.C. 120 of copending U.S. patent application Ser. No. 11/065,157 filed Feb. 25, 2005, which is a continuation in part under 35 U.S.C. 120 of U.S. patent application Ser. No. 10/277,500, filed Oct. 22, 2002 now U.S. Pat. No. 6,861,810, which also claims priority under U.S.C. 119(e) of Provisional Application 60/335,216 filed Oct. 23, 2001. Priority of the present application is also claimed under U.S.C. 119(e) of Provisional Application 60/797,692 filed May 5, 2006.

INTRODUCTION

The present invention relates generally to an organic electroluminescent (EL) device and more particularly to a driving method and apparatus for such a device. This active matrix drive method works for all known types of light-emitting diodes (LED) whose emission electroluminescent layer comprises a film of organic compounds. Examples of different types are small-molecule OLED (SM-OLED), polymer light-emitting diodes (PLED), and phosphorescent OLED (PHOLED).

BACKGROUND

There are two types of organic electroluminescent (EL) display devices, passive (simple matrix) organic EL and active matrix organic EL. Organic EL materials are divided into low molecular weight organic EL materials and high molecular weight (polymer) organic EL materials. Low molecular weight organic EL materials are mainly applied by evaporation to the substrate. High molecular weight or polymer organic EL materials are applied by ink jet printing or similar techniques.

The active matrix drive method works for all known types of light-emitting diodes (LED) whose emission electroluminescent layer comprises a film of organic compounds. Examples of different types are small-molecule OLED (SMOLED), polymer light-emitting diodes (PLED) and phosphorescent OLED (PHOLED).

Small molecule organic EL substances are disclosed in U.S. Pat. Nos. 4,720,432 (VanSlyke et al.), 4,769,292 (Tang et al.), 5,151,629 (VanSlyke), 5,409,783 (Tang et al.), 5,645,948 (Shi et al.), 5,683,823 (Shi et al.), 5,755,999 (Shi et al.), 5,908,581 (Chen et al.), 5,935,720 (Chen et al.), 6,020,078 (Chen et al.), and 6,069,442 (Hung et al.), 6,348,359 (VanSlyke), and 6,720,090 (Young et al.), all incorporated herein by reference.

Large molecule or polymeric OLED substances are disclosed in U.S. Pat. Nos. 5,247,190 (Friend et al.), 5,399,502 (Friend et al.), 5,540,999 (Yamamoto et al.), 5,900,327 (Pei et al.), 5,804,836 (Heegar et al.), 5,807,627 (Friend et al.), 6,361,885 (Chou), and 6,670,645 (Grushin et al.), all incorporated herein by reference. The polymer light-emitting devices may be called PLED.

Organic luminescent substances also include OLEDs doped with phosphorescent compounds as disclosed in U.S. Pat. No. 6,303,238 (Thompson et al.), incorporated herein by reference. Organic photoluminescent substances are also disclosed in U.S. Patent Application Publication Nos. 2002/0101151 (Choi et al.), 2002/0063525 (Choi et al.), 2003/0003225 (Choi et al.) and 2003/0052595 (Yi et al.); U.S. Pat.

Nos. 6,610,554 (Yi et al.) and 6,692,326 (Choi et al.); and International Publications WO 02/104077 and WO 03/046649, all incorporated herein by reference.

Active matrix organic LED devices are difficult to drive using simple two-terminal schemes because of their lack of memory. The rise and decay time of an organic LED device is very fast and it does not have intrinsic memory. To overcome this problem, thin-film-transistor (TFT) circuits have been developed to drive organic LED devices. Such circuits include four or more TFTs, a storage capacitor, and an organic LED pad arranged on a substrate. The storage capacitor enables the excitation power to an addressed organic LED element to stay on once it is selected.

While successfully overcoming the above mentioned problem, new problems in manufacturing are created. The storage capacitor process and deposition are very complicated and difficult to achieve in a fabrication process. The TFTs fabrication requires several mask steps whose difficulty and cost increase dynamically as the display size increases. If the substrate is plastic an expensive laser annealing process is used in fabrication of the TFT.

RELATED PRIOR ART

Electronic Circuitry

The following prior art relates to electronic circuitry for addressing an organic LED display and is incorporated herein by reference: U.S. Pat. Nos. 4,134,132 (Magos et al.), 5,828,181 (Okuda), 6,084,579 (Hirano), 6,356,029 (Hunter), 6,542,138 (Shannon et al.), 6,861,810 (Rutherford), and U.S. Patent Application Publication Nos. 2001/0001050 (Miyashita et al.), 2001/0054711 (Numano), 2002/0047839 (Kasai), 2002/0167474 (Everitt), 2003/0011960 (Koning et al.), and 2004/0084986 (Arbogast et al.).

BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 is a circuit diagram of a capacitor current memory Bimorph MEMS device positioned for address period.

FIG. 2 is a circuit diagram of a capacitor current memory Bimorph MEMS device positioned for light emission.

FIG. 3 is a circuit diagram of a sub-pixel for a Bimorph MEMS device in its OFF position.

FIG. 4 is a diagram of electrode waveforms.

FIG. 5 is a circuit diagram of a sub-pixel for an IPMC MEMS.

FIG. 6 is a diagram of IPMC MEMS electrode waveforms.

FIG. 7 is a sub-pixel one plastic sheet structure top edge view.

FIG. 8 is a sub-pixel two plastic sheet structure side edge view.

SUMMARY OF INVENTION

In accordance with this invention, there is provided a low power active matrix organic LED electroluminescent display device with a capacitor current memory circuit that enables increased component tolerances, and reduces problems caused by dimensional instability of plastic substrates. A Bimorph MEMS device connects a capacitor to the device's column electrode during the addressing period and to the organic LED electroluminescent device during light emission period.

DETAILED EMBODIMENTS

The capacitor current memory drive method and apparatus of this invention makes possible the low cost manufacture of

very large area flexible substrate active matrix organic LED electroluminescent displays including HDTV. In accordance with this invention, display sizes up to 60 inches or more in diagonal can be manufactured. The three basic components in each of the sub-pixels that comprise this display are an organic LED electroluminescent (EL) device, a Bimorph MEMS device, and a memory capacitor. No TFTs are used or required in this active matrix drive method. Thus, some of the disadvantages associated with a TFT active matrix drive, such as more components in each pixel or sub-pixel, close manufacturing tolerances, and higher process temperatures are eliminated. All process temperatures for this display are low temperature and there are no destructive temperatures affecting manufacture on plastic substrates. Manufacturing non-uniformity has a much lesser effect on display brightness uniformity when using this structure compared to that of TFT circuits. The light output from the display is controlled by external ICs supplying a precise amount of charge to the memory capacitors. Because all of this charge is dissipated as forward current through the organic LED electroluminescent device, all pixels have the same light output even though there may be variations in the display's components. Variation in organic LED electroluminescent layer thickness across the display results in sub-pixels having different device threshold voltages. Adjustment to variation and/or changes in organic LED electroluminescent diode threshold voltage due to aging is automatic. Tolerances effecting a variation in sub-pixel size are automatically compensated by small changes in current density through the organic LED electroluminescent device. Therefore, because the display brightness uniformity is controlled by the charge stored in its memory capacitors, it is not necessary that manufacturing tolerances be as closely controlled as they are for the TFT drive method. Also, wide component tolerances helps in the manufacture of very large displays.

Low power results from row and column electrodes made of highly conductive opaque metal such as copper that minimizes the resistive losses in these electrodes. Energy stored in the Bimorph MEMS device during its operation is recovered in the memory capacitor. All charge added to the memory capacitor during the addressing period is used to produce light output. A ramp voltage applied to the memory capacitor controls a small forward current through the organic electroluminescent device. This results in an additional advantage in energy savings over that of the TFT drive method. In the TFT drive method forward current through the organic LED that produces the light output is dissipated to ground. In this drive method forward current through the organic LED is recovered in the V_{offset} power supply. The result of this energy recovery is a power savings resulting in even higher luminescent efficiency than can obtain by the TFT drive method. This display is a front emission type and has a very large aperture ratio (>95%). Typically displays having very large aperture ratio can operate at a better luminous efficiency because of their lower current density.

This new drive method eliminates obstacles to the manufacture of small as well as very large area (60 inch or greater) HDTV organic LED electroluminescent displays on plastic substrates. It has the capability for manufacturing very large area low power organic LED electroluminescent displays with reduced cost and increased performance that cannot be matched by other active matrix drive methods.

DETAILED DESCRIPTION OF THE DRAWINGS

Capacitor Current Memory Drive

FIG. 1 shows the electrical equivalent circuit for driving a cathode front structure organic LED electroluminescent display. The front emissions display with capacitor current

memory drive consists of Row Electrodes 42 connected to the memory capacitors C1 and driven by row ICs 8 with switches SW3 and SW4 and ramp circuit 6 with switches SW1 and SW2. Also shown are Positive Voltage Electrode 44 and Column Electrode 47. The constant current output from the Column Data IC 7 loads a specific amount of charge into the memory capacitors C1. The Column Data IC 7 includes a constant current source 7-1 and switch SW7. There is one common front electrode 61 (V_{offset}) covering the entire front surface area of the display. To prevent excessive reverse bias on the organic LED after completion of the Ramp Voltage 45 (illustrated in FIG. 4) portion of the waveform, a circuit 9 with switches SW5 and SW6 generates the Return to Center OFF Pulse 48 (illustrated in FIG. 4). This pulses the Bimorph MEMS device's 3 bottom electrode a and returns the device to its center OFF position (illustrated in FIG. 3). Also shown is top electrode c, which is grounded. The center electrode b is connected to the positive (+) lead of capacitor C1. Electrodes 42, 47, 61, and 44 interconnect the display sub-pixels components. Each basic sub-pixel 1 has an organic LED electroluminescent device 2, a Bimorph MEMS device 3 and a simple capacitor C1 used as a memory device. Dependent upon the orientation of the sub-pixel components, this front emission display can have either the organic LED electroluminescent device cathode or anode to its front as disclosed in U.S. Pat. No. 6,861,810 (Rutherford), cited above and incorporated herein by reference.

As shown in FIG. 1 the Bimorph MEMS device 3 is positioned for the address period. A mounting block 16 supports the bimorph MEMS device 3. Pad 3-2 makes contact to pad 3-3 during the address period 43 (illustrated in FIG. 4) and to pad 3-1 during the light emission period during ramp voltage 45 (illustrated in FIG. 4). The arrowed line 10 is the current path from the Column Data IC Constant Current Source 7-1 to the Column Electrode 47, through the Bimorph MEMS device 3 center electrode b, then to the memory capacitor C1. The charge stored in C1 is for one video frame. The amount of charge determines the gray scale level for this sub-pixel. As illustrated in FIG. 3, after the address period 43 (illustrated in FIG. 4), the Bimorph MEMS device 3 is repositioned to its center OFF position.

Shown in FIG. 2 is an arrowed line 11 that follows the current path of memory capacitor C1 discharge. The discharge is from C1, through Bimorph MEMS device 3 center electrode b, which is now positioned pad 3-2 to pad 3-1 connecting to the organic LED device 2. The current path 11 continues through the organic LED device 2 to the V_{offset} 61. A ramp voltage on the Row Electrode 42 controls the rate of capacitor C1's discharge through the organic LED device 2. Also, a voltage equal to the Ramp Voltage 45, shown in FIG. 4 plus the voltage from the charge stored in C1, during the addressing period 43, is applied to the Bimorph MEMS device 3 center electrode b. As the voltage increases a level is reached that determines when the Bimorph MEMS device 3 repositions from its center OFF position to the organic LED 2 position as shown in FIG. 2. This process controls the amount of reverse bias voltage that is applied to the organic LED 2 and can be from none to some desired amount. The effect upon the organic LED 2 is a small constant current until the end of the ramp voltage 45, at which time the charge stored in the memory capacitor C1 from the Column Data IC 7 is dissipated. Therefore, the total light emission during this frame time is directly proportional to the amount of charge stored in the memory capacitor C1 during the Address Period 43 in FIG. 4.

Bimorph MEMS Device

Recent advances in electron-irradiated copolymer poly (vinylidene fluoride-trifluoroethylene) exhibit large energy den-

sity and recoverable strains up to 4%. See U.S. Patent Application Publication 2004/0084986 (Arbogast et al.), cited above and incorporated herein by reference. Another novel electromechanical device is ionic polymer metal composite materials. Bimorph actuation of systems utilizing high-density electrostrictive materials presents a compound actuator system. As illustrated in FIG. 3 the Bimorph MEMS device 3 is mounted on mounting block 16. The first 14 and second 15 electrostrictive layers are positioned between the a, b, c electrodes of the Bimorph MEMS device 3. The electrodes a, b, c may be any suitable electrical conductor (gold, copper or aluminum). The electrodes a, b, c may be sheet conductors, or may be conductors that are sputtered or chemically vapor-deposited on the electrostrictive layers 14, 15. As illustrated in FIG. 3 when the voltage across both electrostrictive layers 14, 15 is equal, the Bimorph MEMS device 3 is in the center OFF position. As illustrated in FIG. 1 when the voltage across electrodes a and b is greater than the voltage across electrodes b and c, then the electrostrictive layer 14 between electrodes a and b constricts and positions the Bimorph MEMS device 3 connecting the memory capacitor C1 to the Column Data Electrode 47. As illustrated in FIG. 2 when the voltage across electrodes b and c is greater than the voltage across electrodes a and b, the electrostrictive layer 15 between electrodes b and c constricts and positions the Bimorph MEMS device 3 to connect memory capacitor C1 to the organic LED device 2.

Voltage Waveforms

The voltage waveforms of FIG. 4 are for the Row Electrode 42, Positive Voltage Electrode 44 and Column Electrode 47. The waveforms have a period of time in which the Bimorph MEMS device 3 (FIG. 3) is in the center OFF position, an Addressing Period 43 in which the Bimorph MEMS device 3 (FIG. 3) is positioned to contact the memory capacitor C1 (FIG. 1) and light output period during the Ramp Voltage 45 in which the Bimorph MEMS device 3 (FIG. 3) repositions from the center OFF position to a position making contact to the organic LED device 2 (FIG. 2). During the Addressing Period 43, the SW4 (FIG. 1) is ON and grounds the Row Electrode 42, the result is that the voltage across electrodes a and b is greater than the voltage across electrodes b and c and the Bimorph MEMS device 3 (FIG. 3) is positioned to connect the Column Electrode 47 to the memory capacitor C1 (FIG. 1). This enables charge to be stored in memory capacitor C1 (FIG. 1). The amount of charge added to the memory capacitor C1 (FIG. 1) will result in the desired light output. Charging is stopped by the pulse width modulation (not shown) of Column Data IC 7 (FIG. 1) turning SW 7 OFF. At the end of the Address Period 43 the Row Electrode 42 Waveform steps voltage to V1 such that the voltage across a and b is equal to the voltage across b and c which returns the Bimorph MEMS device 3 (FIG. 3) to the center OFF position. As the Ramp Voltage 45 increases the voltage applied to the Bimorph MEMS device 3 (FIG. 3), center electrode b increases. This center electrode voltage is the sum of the Ramp Voltage 45 plus the voltage level in the memory capacitor C1 (FIG. 3) due to the amount of charge stored in C1 (FIG. 3). When the voltage across electrode b and c reaches a certain level greater than the voltage across electrodes a and b, the Bimorph MEMS device 3 (FIG. 3) repositions from the center OFF position to the organic LED position as discussed for FIG. 2. At this time the increasing Ramp Voltage 45 forces the discharge of capacitor C1 through the organic LED 2 (FIG. 2).

The small forward current level through the organic LED 2 (FIG. 2) is controlled by an equilibrium condition created

when the rate of reduction of the C1 voltage due to discharge, is equal to the rate of voltage rise of the Ramp Voltage 45. At the end of the ramp period, the discharge of C1 stops when its voltage has been reduced to a level that is equal to the organic LED 2 (FIG. 2) threshold voltage. Therefore, the spatial charge voltage remaining on the memory capacitor C1 is indicative of the organic LED 2 (FIG. 2) threshold voltage. The result is each sub-pixel has its own memory for its organic LED 2 (FIG. 2) threshold voltage. In subsequent frames, charge is added to the memory capacitor C1, which is used to produce the desired light output. At the end of the Ramp Voltage 45 a Return to Center OFF Pulse 48 helps return the Bimorph MEMS device 3 (FIG. 3) to its center OFF position before the Ramp Voltage 45 steps down from V2 to V1. This prevents a reverse bias voltage on the organic LED during this step down in voltage.

Ionic Polymer Metal Composites (IPMC) MEMS Device

An IPMC has two parallel electrodes and electrolyte between the electrodes. For this invention an electro-active solid-state actuator comprising a solid polymer electrolyte film having first and second main surfaces facing each other, and first and second conductive polymer layers infiltrated into the first and second main surfaces of the solid polymer electrolyte film.

FIG. 5 illustrates a sub-pixel 50 using the IPMC MEMS device 53. When the voltage is applied from memory capacitor C1 and the bias electrode 54, the First Conductive Polymer Layer 58 and Second Conductive Polymer Layer 59 are caused to be polar. Further, the cationic component of the Solid Electrolyte Film 52 is shifted to Conductive Polymer Layer 58 or 59 as a cathode. Thereby, expansion occurs at the electrolyte portion adjacent to the Conductive Polymer Layer 58 or 59, while constriction occurs at the electrolyte portion adjacent to the other Conductive Polymer Layer. Thus, curvature toward the other Conductive Polymer Layer takes place. Also shown in FIG. 5 is Pad 55-1 for connection to organic LED 2 (FIG. 5), Pad 55-2 for connection to First Conductive Polymer Layer 58 and Pad 55-3 for connection to Column Electrode 47. Dielectric 56 isolates 55-2 from Second Conductive Polymer Layer 59.

FIG. 6 illustrates the voltage waveforms controlling the IPMC MEMS device 53 (FIG. 5). When both the Bias Electrode waveform 64 and Row Electrode waveform 62 are at voltage V1, the IPMC MEMS 53 (FIG. 5) device is in its center OFF position. During the Address Period 63 the Row Electrode 42 grounds memory capacitor C1 (FIG. 5) and the Bias Electrode waveform 64 is at V1. In this case the memory capacitor C1+ voltage to First Conductive Polymer Layer 58 (FIG. 5) results in expansion of the solid electrolyte film at this electrode and constriction at 59. Thus, curvature to the Column Electrode 47 takes place to make the connection between the Column Electrode 47 (FIG. 5) and Memory Capacitor C1. After the Address Period 63, the voltage applied to the First Conductive Polymer Layer 58 is the charge stored in the Memory Capacitor C1 (FIG. 5) plus the voltage level due to increasing Ramp Voltage 65 (FIG. 6). When the voltage level is reached such that the constriction of the Solid Electrolyte Film 52 (FIG. 5) at the Memory Capacitor C1 (FIG. 5) and the expansion at the Bias Electrode 54 (FIG. 5) results in enough curvature to make contact to the Pad 55-1 and organic LED 2 (FIG. 5). The Memory Capacitor C1 then discharges through the organic LED 2 (FIG. 5) while the current level is controlled by the rate of Voltage Ramp 65 increase. At the end of the Ramp Voltage 65 a Return to Center

OFF Pulse 66 helps return the IPMC MEMS device to its center OFF position before the Ramp Voltage goes down from V2 to V1. This prevents a reverse bias of the organic LED 2 (FIG. 5).

Single Substrate Structure

The structure for the organic LED electroluminescent display can have all its components located on its topside or on both sides of a single substrate 76 such as a plastic sheet. Illustrated in FIG. 7 is one sub-pixel whose components are on both sides of a single substrate 76. On the topside are the protective cover 70, buffer layer 71, translucent cathode electrode 72, organic luminescent layers 73, and optical trap consisting of a thin metal layer 74-1, a transparent conductive layer 74-2, organic LED anode electrode 74-3. A plated through hole 76-1 makes connection between anode electrode 74-3 to bottom side of plastic substrate 76 pad 76-2. On the bottom side are the Bimorph MEMS device 3 (FIG. 7) and memory capacitor C1. This display is a top emission type and in the figure the organic LED cathode is to the front. However, by changing the orientation of components and waveforms the organic LED anode electrode can be to the front.

In the display's plastic substrate 76, each sub-pixel has a plated through hole 76-1, which makes the electrical connection between the top and bottom surfaces. Metal on the top-side is formed into the shape of the organic LED anode electrodes 74-3. A metal pad 76-2 on the bottom side is for contact to the Bimorph MEMS device 3 (FIG. 7) pad 76-3.

The topside processes begin with a destructive-interference contrast-enhancement stack. This stack has three layers consisting of the anode electrode 74-3, transparent layer 74-2 and thin metal layer 74-1 that are formed into the shape of the sub-pixel. These layers also serve as the anode electrode for the organic light-emitting device. Next partitioning walls 75 (banks) are formed to fill the spaces between the sub-pixel electrodes. The organic luminescent layers 73 are formed in vertical strips of red, green, and blue color. The translucent cathode layer 72 covers the entire front surface area of the display. A buffer layer 71 covers the cathode layer 72. Finally the cover layer 70 seals the display. To be noted the anode electrode 74-3 is flat, therefore the organic luminescent layers have a flat surface to be formed upon. As stated earlier the display can also be configured as a top emission type with the anode to the front. These different structure types for this display apparatus are discussed in previous papers.

Next testing of the organic electroluminescent layers selects reliable devices and the display process is continued. For those rejected displays, processing is discontinued, which results in a cost saving.

The bottom side processing continues with a spacer layer 70s with an open area for the Bimorph MEMS device 3 (FIG. 7). The first part of the open area is filled with a temporary material. Then a metal pad 76-3 and c electrode are formed. A ground electrode is formed on the spacer layer. A second electrostrictive layer 15 is added to the c electrode. A spacer layer (not shown) equal to the thickness of the electrostrictive layer is added. A b electrode is formed on the second electrostrictive material 15 and also, extends to a plated through hole 78-1. A first electrostrictive layer 14 is formed on the b electrode. A spacer layer (not shown) equal to the first electrostrictive layer 14 is added. The a electrode and pad 76-4 is formed on the first electrostrictive material 14. The pad 76-4 is used to make contact to the column electrode 47. The temporary material (not shown) under the c electrode is removed by under etching. A positive voltage electrode 44 is formed on the spacer layer and makes connection to the a

electrode. An insulating film 77 fills the area between the spacer layer 70s and the metal for the Memory Capacitor C1 second electrode 78 which is deposited and formed into the shape of a sub-pixel. A space 77-1 between second electrodes 78 isolates each C1. A memory capacitor dielectric layer 79 covers the entire surface. See U.S. Patent Application Publication 2003/0011960 (Koning et al.), incorporated herein by reference. Also see Y. Bai, Z.-Y. Cheng, V. Bharti, H. S. Xu, and Z. M. Zhang, "High-dielectric-constant ceramic-powder polymer composites", Appl. Phys. Lett., Vol. 76, No. 25, 2000, cited above and incorporated herein by reference. Metal is deposited on the dielectric surface and formed into horizontal row electrodes 42 (memory capacitor first electrode). The memory capacitor second electrode 78, memory capacitor dielectric 79 and row electrode 42 make memory capacitor C1. This completes the components on the bottom side.

Dual Substrate Structure

The dual substrate structure is such that manufacturing can be performed on three separate parts of the display simultaneously. Shown in FIG. 8 is the structure for a side view of a pixel.

The Memory Capacitor C1 is on the substrate 80s. Row electrodes 42 are formed on the substrate 80s. These electrodes also serve as the memory capacitors C1 first electrode. A dielectric layer 89 is formed covering the entire display area of the substrate. A metal for the memory capacitors second electrode 88 is deposited upon the dielectric layer and then formed into its sub-pixel shape. The processing of the Row Electrode 42, Memory Capacitor dielectric 89 and Memory capacitor second electrode 88 completes Memory Capacitor C1.

The first plastic substrate 87 such as a plastic sheet has interconnects for the memory capacitors second electrode 88. It also has the MEMS device and its mounting. A conductive through hole 87-1 for each sub-pixel makes the electrical connection from the memory capacitor C1 second electrode 88 to the topside of the plastic sheet 87. Vertical column data electrodes 47 are formed on this topside. A nonconductive material 85-2 is formed in horizontal strips across the first plastic substrate 87. An opening is maintained at the through hole location 87-1. A ground electrode is formed on top of the horizontal stripe 85-2. Also, during this process metal 87-2 from the through hole 87-1 to the top of the horizontal stripe makes an electrical conductor for the MEMS device center electrode b. The elements of the MEMS device are formed on a transfer substrate. The transfer substrate is moved to the first plastic sheet substrate 87 and the MEMS device is mounted upon the ground electrode. Conductive adhesive makes the electrical contact from ground electrodes to electrode a and metal 87-2 from through hole 87-1 to center electrode b of the MEMS device. The transfer substrate (not shown) is removed through a liftoff process, using radiation energy, such as from laser or other appropriate device. The positive voltage electrode 44 is formed across the display connecting to the c electrode of the MEMS device. A nonconductive spacer layer 85-1 is formed filling the space above the positive voltage electrode 44 and the horizontal strip-mounting layer 85-2. This completes the processing of the first plastic substrate 87.

The organic LED device is on the second plastic substrate 86. There is a conductive through hole 86-1 for each sub-pixel. On the bottom side, at the conductive through hole, is a pad 86-2 area used for contact to pad 86-3, which is connected to the cantilever Bimorph MEMS device center b electrode. The topside of the second plastic substrate begins with the

anode electrode **84** for the organic light-emitting device connected to through hole **86-1**. Next partitioning walls (banks not shown) are formed to fill the spaces between the sub-pixels electrodes. Organic luminescent layers **83** are formed in vertical strips of red, green and blue color. A translucent cathode layer **82** covers the entire front surface display area. A buffer layer **81** covers the cathode layer. Finally the protective cover layer **80** is added to the front of the display.

Mating the part with the MEMS device to the part with the memory capacitor and then the part with the organic LED device to the part with the MEMS device completes the assembly of the display.

Display Life

This front emission type display has a very large aperture ratio. The resultant lower current density will increase life due to less heating of the organic LED element and less metal migration.

The organic LED electroluminescent layers reversed bias may be controlled to some desired amount. It is known that application of reverse bias to an organic LED electroluminescent element is an effective means to increase the life of the display. See U.S. Patent Application Publication 2002/0047839 (Kasai), cited above and incorporated herein by reference.

The spatial charge voltage on the memory capacitor is indicative of the threshold voltage of the organic LED device. It has been recognized that as the organic LED display elements degrade over time, their impedance increases and the potential difference between anode and cathode increases. The value of the change in potential difference provides a reasonable indication of the state of the element in terms of its light emission/drive current characteristic. See U.S. Pat. No. 6,356,029 (Hunter), cited above and incorporated herein by reference. Thus by using feedback of this voltage to adjust the amount of charge stored in each memory capacitor **C1**, compensation for temperature and aging degradation is possible.

Low Power

The row and column electrodes are made of highly conductive opaque metal such as copper. A resistive loss in these electrodes is minimal. Much of the energy used to drive the organic LED electroluminescent display is restored to the power supply and recovered in the memory capacitor. For example the energy of the forward current through the organic LED during the light emission is recovered in the V_{offset} power supply. Charge stored in the MEMS device is recovered in **C1**. These energy recovery methods result in significant reduction of power consumed by this display. This display is a front emission type and has a very large aperture ratio. Displays having very large aperture ratio can operate at a better luminous efficiency because of their lower current density.

Wide Component Tolerance

Manufacturing non-uniformity has a lesser effect on display brightness uniformity, when using this structure compared to that of TFT circuits. The light output from the display is controlled by external ICs supplying a precise amount of charge to the memory capacitor **C1**. Because all of this charge is dissipated as forward current through the organic LED device, all pixels have the same light output even though there are variations in the display's components. For example the memory capacitor value can vary because of non-uniform dielectric thickness and/or electrode area. Variation in organic

LED layer thickness results in sub-pixels with different organic LED device threshold voltages across the display. The spatial charge voltage remaining in the memory capacitor helps compensates for these different threshold voltages. Tolerances affecting sub-pixel size are automatically compensated by small changes in current density through the organic LED. Therefore, because the display brightness uniformity is controlled by the charge stored in its memory capacitors, it is not as important that manufacturing tolerances be as closely controlled.

Display Brightness Uniformity

The capacitor current memory structure uses external column data IC's for driving the column electrode. The currents from these crystalline silicon drivers will always be more accurate and stable than that of the TFT pixel circuits. Light output is directly proportional to the amount of charge stored in the memory capacitors **C1**. All sub-pixel memory capacitors **C1** have the same charge added to them regardless of circuit variations. A more accurate charge stored in the memory capacitor results in better display brightness uniformity.

Adjustment to variation and/or changes in organic light-emitting diode threshold voltage is automatic. This is because after producing light by discharging the memory capacitor **C1** through the organic light-emitting diode a spatial voltage equal to the threshold voltage of the organic LED remains on the memory capacitor **C1**. In subsequent display cycles charge is added to the memory capacitor **C1** proportional to the desired display brightness.

Memory Capacitor Capability of Storing One Complete Frame of Data

The memory capacitor is able to store enough charge during an address period to light the display for a complete frame period. Therefore, sub-field addressing and the resultant visual artifacts are eliminated.

Deep Color

This large display can be addressed at very high speed. This results in a 120 Hz frame rate capability. An extended color gamut and 16-bit depth per color is then possible.

SUMMARY

The new drive method eliminates obstacles to the manufacture of very large area organic LED displays on plastic substrates. It has the capability for manufacturing low power very large area organic LED displays with reduced cost and increased performance that cannot be matched by other active matrix drive methods.

The foregoing description of various preferred embodiments of the invention has been presented for purposes of illustration and description. It is not intended to be exhaustive or to limit the invention to the precise forms disclosed. Obvious modifications or variations are possible in light of the above teachings. The embodiments discussed were chosen and described to provide the best illustration of the principles of the invention and its practical application to thereby enable one of ordinary skill in the art to utilize the invention in various embodiments and with various modifications as are suited to the particular use contemplated. All such modifications and variations are within the scope of the invention as

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determined by the appended claims to be interpreted in accordance with the breadth to which they are fairly, legally, and equitably entitled.

The invention claimed is:

1. In an active matrix organic LED display having a matrix of multiple light emitting pixels and electronic drive circuitry for addressing said pixels, each pixel containing an organic LED, said display including row scan electrodes and column data electrodes that interconnect said pixels, the improvement wherein said electronic circuitry comprises a MEMS switching device and a memory capacitor for each pixel, said MEMS switching device connecting said memory capacitor to a column data electrode during addressing of a pixel and said MEMS switching device connecting said memory capacitor to the organic LED of said pixel during light emission.

2. The invention of claim 1 wherein said organic LED is a small molecule organic light-emitting diode.

3. The invention of claim 1 wherein said organic LED is a polymer light-emitting diode.

4. The invention of claim 1 wherein said organic LED is a phosphorescent organic light-emitting diode.

5. The invention of claim 1 wherein said memory capacitor has storage capacity for one complete frame of light output.

6. The invention of claim 1 wherein said row and column electrodes are made of a highly conductive opaque substance.

7. The invention of claim 1 wherein said row and column electrodes are made of copper.

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8. In a method for operating an active matrix organic LED display having a multiplicity of light emitting pixels and electronic drive circuitry for selectively addressing said pixels, each pixels containing an organic LED, said display including row scan electrodes and column data electrodes that interconnect the matrix of pixels with a MEMS switching device and a memory capacitor for each pixel, the improvement wherein said MEMS switching device connects said memory capacitor to a column data electrode during addressing of a pixel and wherein said MEMS switching device connects said memory capacitor to said organic LED of said pixel during light emission.

9. The invention of claim 8 wherein said memory capacity has storage capacity for one complete frame of light output.

10. The invention of claim 8 wherein said row and column electrodes are made of copper.

11. The invention of claim 8 wherein said organic LED is a small molecule organic light-emitting diode.

12. The invention of claim 8 wherein said organic LED is a polymer light-emitting diode.

13. The invention of claim 8 wherein said organic LED is a phosphorescent organic light-emitting diode.

14. The invention of claim 8 wherein the energy stored in the memory capacitor during the addressing period is recovered during light emission.

* * * * *

专利名称(译)	使用双压电晶片MEMS器件的大面积有机电致发光显示器		
公开(公告)号	US7714514	公开(公告)日	2010-05-11
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[标]申请(专利权)人(译)	成像SYST TECH PPD SYST		
申请(专利权)人(译)	成像系统技术 PPD系统		
当前申请(专利权)人(译)	成像系统技术 PPD系统		
[标]发明人	RUTHERFORD JAMES C		
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代理机构(译)	婚礼, DONALD K.		
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外部链接	Espacenet USPTO		

摘要(译)

一种有源矩阵有机LED显示器，具有多个发光像素矩阵和用于选择性地寻址像素的电子驱动电路，每个像素包含有机LED。电子驱动电路包括互连像素矩阵的行扫描电极和列数据电极。该电路还包括用于每个像素的MEMS开关器件和存储电容器，MEMS开关器件在像素寻址期间将存储电容器连接到列数据电极，并且在光发射期间将存储电容器连接到每个像素的有机LED。

